



ITW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Katsuyoshi NAKATSUKASA et al.**

Art Unit: **1792**

Application Number: **10/562,967**

Examiner: **Duy Vu Nguyen Deo**

Filed: **December 29, 2005**

Confirmation Number: **7895**

For: **SUBSTRATE PROCESSING METHOD AND SUBSTRATE PROCESSING
DEVICE**

Attorney Docket Number: **053513**

Customer Number: **38834**

RESPONSE UNDER 37 C.F.R. § 1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

June 19, 2009

Sir:

In response to the Office Action dated March 27, 2009, Applicants submit the following remarks, which begin on page 2 of this paper.